



IAP15 Rec'd PCT/PTO 18 OCT 2006

PCT#

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

Seiji AKITA et al.

Serial No. 10/576,476

Filed April 20, 2006

NANOSIZE HEATER-MOUNTED NOZZLE  
AND METHOD FOR MANUFACTURING  
SAME AND METHOD FOR FORMING  
MICRO THIN FILM

[Corresponding to PCT/JP2004/015598

Filed October 21, 2004]

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: Mail Stop: MISSING PARTS

: Attorney Docket No. 2006\_0598A

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

**PATENT OFFICE FEE TRANSMITTAL FORM**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$130.00 to cover Patent Office fees relating to filing the following attached papers:

Late filing of executed Declaration ..... \$130.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

10/23/2006 ATRAN1 00000107 10576476

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130.00 DP

Respectfully submitted,

Seiji AKITA et al.

By

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Registration No. 33,142

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October 18, 2006

[Check No. 76794]

2006\_0598A



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In re application of :  
Seiji AKITA et al. : **Mail Stop: MISSING PARTS**  
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**SUBMISSION OF EXECUTED DECLARATION UNDER 35 USC 371**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:


Submitted herewith is a Declaration for the above application executed by the inventors.

Also enclosed are the PTO surcharge of **\$130.00** required by 37 CFR 1.492(e).

It is respectfully submitted that the application is now complete, and early indication  
thereof is now requested.

Respectfully submitted,

Seiji AKITA et al.

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Charles R. Watts  
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October 18, 2006

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**SUBMISSION OF ENGLISH VERSIONS OF INTERNATIONAL PRELIMINARY  
REPORT ON PATENTABILITY AND WRITTEN OPINION OF THE  
INTERNATIONAL SEARCHING AUTHORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith for consideration by the Examiner are:

- 1) An English version of the International Preliminary Report on Patentability; and
- 2) An English version of the Written Opinion of the International Searching

Authority.

Respectfully submitted,

Seiji AKITA et al.

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